

Application/Control No.		Applicant(s)/Patent under Reexamination	
10/689,629	KIM ET AL.		
Examiner	Art Unit	,	
George A. Goudreau	1763		

SEARCHED				
Class	Subclass	Da	ate	Examiner
438	41	6-	06'	GAG
438	60			GAG
438	75			GAG
438	694			GAG
438	745			GAG
438	752	7	7	GAG

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date		Examiner	
438	41	6-	261	GAG	
438	60			GAG	
438	75	\ \	7	GAG	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
STN: CAPLUS, JAPIO, INSPEC, USPAT2	6-06	GAG
EAST: USPB, USPT, WPID, JPO	4	GAG
•		

Search Notes (continued)

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/689,629	KIM ET AL.	
Examiner	Art Unit	
George A. Goudreau	1763	

SEARCHED				
Class	Subclass	Date	Examiner	
	-			
	,			

INTERFERENCE SEARCHED				
Class	Subclass	Date		Examiner
438	694	6-06'		GAG
438	745			GAG
438	752	7	7	GAG

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE EXI			
		i		
•				
·				